

Electronic Acknowledgement Receipt

EFS ID:	2083538
Application Number:	10524980
International Application Number:	
Confirmation Number:	3254
Title of Invention:	Low temperature deposition of silicon oxides and oxynitrides
First Named Inventor/Applicant Name:	Yoshihide Senzaki
Customer Number:	32940
Filer:	Maria S. Swiatek/Deborah Carney
Filer Authorized By:	Maria S. Swiatek
Attorney Docket Number:	A-71722/MSS (463035-860)
Receipt Date:	14-AUG-2007
Filing Date:	22-MAR-2006
Time Stamp:	21:36:03
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	67538-5172_IDS_Ref.pdf	234341 251bfb4061693ea0ff2184a529b592bff9 feae9	no	5

Warnings:

Information:					
This is not an USPTO supplied IDS fillable form					
2	Foreign Reference	67538-5172_EP_Ref.pdf	634278	no	10
			3b90aed1cd8799cf22112ba7ee813c55857a38c		
Warnings:					
Information:					
3	Foreign Reference	67538-5172_KR_Ref.pdf	612568	no	8
			ca1a52eb7927d9e1dc4f5790fcd1c68fff923c82		
Warnings:					
Information:					
4	Foreign Reference	67538-5172_WO_Ref.pdf	1604029	no	50
			10d3d545572f5f4935d2715ffbfaf4e2e24544b		
Warnings:					
Information:					
5	NPL Documents	67538-5172_GORDON_Ref.pdf	246935	no	2
			dc44a0edfa91509521403caf518972d517123876		
Warnings:					
Information:					
6	NPL Documents	67538-5172_Hausmann_Ref.pdf	940420	no	11
			14f620c46baf98ba9358ff8d23bc6f2055638f91		
Warnings:					
Information:					
7	NPL Documents	067538-5172_KUKLI_Ref.pdf	434802	no	6
			94b1d88c78c4a797c76360bc8cc5fc69abe0eaa0		
Warnings:					
Information:					
8	NPL Documents	67538-5172_PCT25739_Ref.pdf	231077	no	4
			a1e9eb0793489565049005961278b502ca29b5d8		
Warnings:					
Information:					
9	NPL Documents	67538-5172_PCT25738_Ref.pdf	259214	no	4
			7a21eb3952e84fd9ffc7f23ce8cc3ec949d19afa		
Warnings:					
Information:					

10	NPL Documents	67538-5172_PCT26083_Ref.pdf	328187 eefc18db5ae0c060bbcb37968e874a353a7a8c4e	no	5
Warnings:					
Information:					
Total Files Size (in bytes):				5525851	
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p> <p><u>New International Application Filed with the USPTO as a Receiving Office</u> If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.</p>					